

WHAT IS CLAIMED IS:

1. - 19. (canceled)

20. (currently amended) A stacked film arrangement comprising:  
at least two one stamped anode film and at least one stamped cathode film,  
wherein the stamped anode and cathode films, wherein the at least two stamped films  
each have a stamped perforation pattern defining at least one dividing line and  
predetermining the edges of cut for future separation into individual elements, wherein said  
at least one dividing line is interrupted in a regular pattern by webs, wherein the webs each  
have a width that is, on average, less than an average spacing between two adjacently  
positioned ones of the webs, respectively, wherein the ~~at least two~~ stamped anode and  
cathode films are stacked flat on top one another without being folded with interposition of  
a separator film that electronically separates the stamped anode and cathode films and are  
superimposed in a staggered arrangement relative to one another such that the webs of  
~~a first one of the at least two one stamped anode film films and the webs of a second one~~  
~~of the at least two one stamped cathode film films~~ are not superimposed, the stacked film  
arrangement forming a compound film.

21. (currently amended) The stacked film arrangement according to claim  
20, wherein the stamped perforation patterns of the ~~at least two~~ stamped anode and  
cathode films are identical and wherein a first the second one of the at least two stamped  
anode film and cathode films is arranged relative to a second the first one of the at least  
~~two stamped anode and cathode films in a rotated position films so as to be rotated by~~  
180° about a surface axis of the first one of the ~~at least two~~ stamped anode and cathode  
films.

22. (currently amended) The stacked film arrangement according to claim  
20 configured to produce electrochemical or electrochromic components.

23. (canceled)

24. (currently amended) The stacked film arrangement according to claim  
20, wherein the ~~at least two~~ stamped perforation patterns of the stamped anode and  
cathode films each have, in a first direction, several of the at least one dividing line dividing  
lines and wherein said several of the at least one dividing line that extend parallel to one  
another, wherein in the stacked film arrangement upon mirroring the a first one of the at

~~least two stamped anode and cathode films is arranged in a mirrored position, mirrored at a mirror plane intersecting the said first one of the at least two stamped anode and cathode films centrally and perpendicularly to said several of the at least one dividing lines line, respectively, and the webs of said several of the at least one dividing lines in the mirrored position are not line will not be superimposed on webs of a the second one of the at least two stamped anode and cathode films that has not been mirrored when superimposing the mirrored first one of the at least two stamped films and the second one of the at least two stamped films that has not been mirrored.~~

25. (currently amended) The stacked film arrangement according to claim 20, wherein the ~~at least two stamped perforation pattern of the~~ stamped anode and cathode films each have several of the ~~at least one dividing lines line and said several of the at least one dividing line that~~ extend perpendicularly to one another in a first direction and in a second direction, wherein ~~the webs of said several of the at least one dividing line that extend in said first direction, upon mirroring of the a first one of the at least two stamped anode and cathode films is arranged in a mirrored position, mirrored at a mirror plane, which mirror plane intersects said the first one of the at least two stamped anode and cathode films centrally and perpendicularly to said first direction, and the webs of said several dividing lines that extend in said first direction are~~ will not be superimposed in the mirrored position on webs of the a second one of the at least two stamped anode and cathode films that has not been mirrored ~~when superimposing the mirrored first one of the at least two stamped films and the second one of the at least two stamped film that has not been mirrored.~~

26. (currently amended) The stacked film arrangement according to claim 20, wherein the ~~at least two stamped perforation patterns of the~~ stamped anode and cathode films each have the webs arranged such that a first one of the stamped anode and cathode films is arranged in a rotated position, rotated upon rotation by 180° about a central axis of rotation that is positioned perpendicularly to a surface plane of the said first one of the at least two stamped anode and cathode films, and the webs of said first one of the stamped anode and cathode films in the rotated position are will not be superimposed on the webs of the a second one of the at least two stamped anode and cathode films that has not been rotated ~~when superimposing the rotated first one of the at~~

~~least two stamped films on the second one of the at least two stamped films that has not been rotated.~~

27. - 33. (canceled)

34. (currently amended) The stacked film arrangement according to claim 20, wherein the ~~at least two~~ stamped anode and cathode films are joined to one another.

35. (currently amended) The stacked film arrangement according to claim 20, wherein the ~~at least two~~ stamped anode and cathode films are laminated to one another.